

Electronic Acknowledgement Receipt

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Application Number:	10550897
International Application Number:	
Confirmation Number:	1704
Title of Invention:	Chemical vapor deposited film based on a plasma cvd method and method of forming the film
First Named Inventor/Applicant Name:	Akira Kobayashi
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Attorney Docket Number:	Q90606
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Application Type:	U.S. National Stage under 35 USC 371

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File Listing:					
Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed	Q90606_IDS.pdf	68512	no	1
			22babeff151c9ef7035cf5d1243dbb1143287816		
Warnings:					
Information:					
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2	Information Disclosure Statement Letter	Q90606_IDSletter.pdf	84101	no	2
			0d56a607dea389792dea7cea311ee41644256ce1		
Warnings:					
Information:					
3	Foreign Reference	Q90606_EP1561840.pdf	2230915	no	43
			212f6395278b5849eab44de0e781d6cb87022d7c		
Warnings:					
Information:					
4	Foreign Reference	Q90606_WO0210473.pdf	1008973	no	23
			ea61bb3700b1279a3c7fc869eca60b6ed2b79522		
Warnings:					
Information:					
5	NPL Documents	Q90606SupplSearchReport.pdf	140524	no	3
			8ebb12e79681fdcc9226eff1d4f455bac9d69ec0		
Warnings:					
Information:					
6	Fee Worksheet (PTO-06)	fee-info.pdf	8232	no	2
			c2b79930ef8068a72ca0e78fd572ee897c96989d		
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Total Files Size (in bytes):			3541257		

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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

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